

SON-1690



PATENT APPLICATION

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Patent Application of

Ichiro FUJIWARA

Serial No.: 09/431,076

Filed: November 1, 1999

For: NONVOLATILE SEMICONDUCTOR  
MEMORY DEVICE AND PROCESS  
OF PRODUCTION AND WRITE  
METHOD THEREOF

Art Unit: 2813

Examiner: J. Chen

**RESPONSE ELECTING INVENTION**

Assistant Commissioner of Patents  
Washington, DC 20231

Sir:

In full and timely response to the Official Action of February 6, 2001 (Paper No. 06), the Applicant, through its representatives and attorneys, hereby elects the invention of Group II, having claims 1 to 22, apparently drawn to a semiconductor device, classified in class 257, subclass 300+. Please hold the claims 13 to 27 and 28 to 51, for Groups I and III respectively, in abeyance pending a filing of divisional applications as of right.

The Applicant preserves its right under MPEP §821.04 to rejoin withdrawn process of making and/or process of using claims when elected product claims are found to be allowable.

The Office Action was said to be "[r]esponsive to communication(s) filed on Nov 1, 1999", without acknowledgement of the Preliminary Amendment filed on May 2, 2000.

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PATENT APPLICATION

An early examination on the merits of the elected claims is respectfully requested.

Respectfully submitted,

*Em Tan* 4/1, 5/8

Date: March 1, 2001

*for* Ronald P. Kananen  
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